

a drying unit in which the substrate is dried.

19. (New) The apparatus of claim 18, wherein the first washing unit, the processing unit, the second washing unit, and the drying unit are arranged as a series of processing vessels with the carrying unit transporting the substrate among the plurality of processing vessels.

20. (New) The method of claim 14, wherein the wiring metal is copper.

21. (New) The method of claim 14, further comprising washing the polished substrate to eliminate particles therefrom, after polishing the substrate to remove the metal residing higher than the upper peripheral level of the first concavity to leave the first metal layer in the first concavity.

REMARKS

The foregoing amendments are made in accordance with amendments made under Article 34 of PCT during the prosecution of the PCT in the international phase.

If there is any fee due in connection with the filing of this Preliminary Amendment, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

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